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CONFIRMATION NO. 1120

Shuichi Kikuchi, Gunma, JAPAN; Eiji Nishibe, Gunma, JAPAN; *** CONTINUING DATA **********************************											
Shuichi Kikuchi, Gunma, JAPAN; Eiji Nishibe, Gunma, JAPAN; ****CONTINUING DATA ****** ****FOREIGN APPLICATIONS ****** JAPAN P2000-318806 10/19/2000 IF REQUIRED, FOREIGN FILING LICENSE GRANTED ***10/04/2001 Foreign Priority claimed 35 USC 119 (a-d) conditions allowance			08/31/2001					DOCKET NO.			
Eiji Nishibe, Gunma, JAPAN; ****CONTINUING DATA ****** ****FOREIGN APPLICATIONS ***** JAPAN P2000-318806 10/19/2000 IF REQUIRED, FOREIGN FILING LICENSE GRANTED ***10/04/2001 Foreign Priority claimed	APPLICANTS										
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